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- REEL: 017766 FRAME: 0146

PATENT
ASSIGNMENT

For good and valuable consideration, the receipt of which is hereby acknowledged, Dong-il Cho, Da-1004, Samho-Apartment, Bangbae-Dong, Socho-Ku, Seoul 137-060, Republic of Korea hereby assigns, sells and transfers all right, title and interest in and to the following U.S. patent, and the inventions disclosed and claimed therein, to SEOUL NATIONAL UNIVERSITY INDUSTRY FOUNDATION, a legal entity of Republic of Korea, doing business at #222 2nd Fl., Seoul National University Research Park Main Center, San 4-2, Bong-chun 7 Dong, Kwanak-Gu, Seoul, Republic of Korea:

U.S. Patent No. 6,988,408, issued on January 24, 2006, entitled
"Surface/bulk Micromachined Single-Crystalline Silicon Micro-Gyroscope".

This Assignment includes the right to sue for any past infringement and retain all recoveries therefor.

Dated : March 3, 2006

By



Printed name: Dong-il Cho